

10/568158

AP20 RCPD PCT/PTO 13 FEB 2006

S/N unknown

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: NAKAGAWA Examiner: unknown

Serial No.: Unknown Group Art Unit: Unknown

Filed: Concurrent herewith Docket: 10873.1842USWO

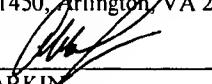
Title: METAL PATTERN AND PROCESS FOR PRODUCING THE SAME

**CERTIFICATE UNDER 37 CFR 1.10**

Express Mail mailing label number: EV 858803201 US

Date of Deposit: FEBRUARY 13, 2006

I hereby certify that the papers listed below are being deposited with the United States Postal Service Express Mail Post Office to Addressee service under 37 CFR 1.10 in an envelope addressed to: Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Arlington, VA 22313-1450.

By: 

Name: ABBIE LARKIN

INFORMATION DISCLOSURE STATEMENT (37 C.F.R. § 1.97(c))

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

With regard to the above-identified application, the items of information listed on the enclosed Form 1449 are brought to the attention of the Examiner. At least some of the references were recently cited in an International Search Report, mailed May 10, 2005.

This statement should be considered because it is submitted within three months of the filing date of the above-identified application, which is not an application under 37 C.F.R. §1.53(d). Accordingly, no fee is due for consideration of the items listed on the enclosed Form 1449.

In accordance with 37 C.F.R. §1.98(a)(2), a copy of each non-U.S. document or other information listed on the enclosed Form 1449 is provided. A copy of the

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /M.D./

JP 2000-155429 PTO 13 FEB 2006

International Search Report is enclosed. Applicants believe that the references from the ISR are available to the Examiner and therefore are not supplying copies.

A concise explanation of the relevance of each non-English language document or other information is as follows (37 C.F.R. §1.98(a)(3)):

JP 3245410 is equivalent to JP 2000-155429.

No representation is made that a reference is "prior art" within the meaning of 35 U.S.C. §§ 102 and 103 and Applicants reserve the right, pursuant to 37 C.F.R. § 1.131 or otherwise, to establish that the reference(s) are not "prior art." Moreover, Applicants do not represent that a reference has been thoroughly reviewed or that any relevance of any portion of a reference is intended.

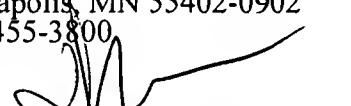
Consideration of the items listed is respectfully requested. Pursuant to the provisions of M.P.E.P. 609, it is requested that the Examiner return a copy of the attached Form 1449, marked as being considered and initialed by the Examiner, to the undersigned with the next official communication.

Respectfully submitted,

HAMRE, SCHUMANN, MUELLER &  
LARSON, P.C.  
P.O. Box 2902  
Minneapolis, MN 55402-0902  
(612) 455-3800

Dated: February 13, 2006

By: \_\_\_\_\_

  
Douglas P. Mueller  
Reg. No. 30,300

DPM:nel

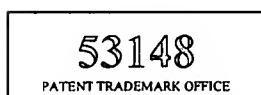
ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /M.D./

<b>FORM 1449*</b> <b>INFORMATION DISCLOSURE STATEMENT</b> <b>IN AN APPLICATION</b> (Use several sheets if necessary)			Docket Number: 10873.1842USWO	Applicant ID: UNKNOWN
			Applicant: NAKAGAWA	
			Filing Date: concurrent herewith	Group Art Unit: UNKNOWN

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	2002/0151161 A1	10.17.2002	FURUSAWA			
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES
	2002-299833	2002.10.11	JP			abstract
	2002-324966	2002.11.8	JP			abstract
	10-204350	1998.8.4	JP			abstract
	2002-13487	2002.1.18	JP			abstract
	3245410	2001.10.26	JP			abstract
	2000-340928	2000.12.8	JP			abstract
	2003-149831	2003.5.21	JP			abstract
	2000-282240	2000.10.10	JP			abstract
	11-174683	1999.07.02	JP			abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
		W.H. Loh et al., "All-solid state subpicosecond passively mode locked erbium-doped fiber laser" Appl. Phys. Lett. Vol. 63 (1), American Institute of Physics, 1993, pp. 4-6.
		J.A. Rogers et al., "Printing, molding, and near-field photolithographic methods for patterning organic lasers, smart pixels and simple circuits", Synthetic Metals, vol. 115, 2000, pp. 5-11.



EXAMINER	/Mahmoud Dahimene/	DATE CONSIDERED	11/04/2009
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.			